

Notice of References Cited	Application/Control No. 10/085,226	Applicant(s)/Patent Under Reexamination PARRISH ET AL.	
	Examiner Christine Sung	Art Unit 2878	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0213910 A1	11-2003	Anderson et al.	250/338.1
	B	US-2003/0146383 A1	08-2003	Knauth et al.	250/338.1
	C	US-6,300,616 B1	10-2001	Regensburger, Martin	250/214LA
	D	US-5,756,999 A	05-1998	Parrish et al.	250/332
	E	US-2002/0040967 A1	04-2002	Oda, Naoki	250/338.1
	F	US-6,441,372 B1	08-2002	Kawahara, Akihiro	250/332
	G	US-6,028,309 A	02-2000	Parrish et al.	250/332
	H	US-6,359,460 B1	03-2002	Tanaka, Akio	324/765
	I	US-2003/0122077 A1	07-2003	Kaufman et al.	250/332
	J	US-6,267,501 B1	07-2001	Wand et al.	374/124
	K	US-2003/0006374 A1	01-2003	McManus, Timothy J.	250/338.1
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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